	F INFORMATION DISCLO Under 37 CFR 1.97(b) or 1.97	SURE STATEMENT (c))	Docket No. SEC.850		
In Re Application:	Yong-joon CHO et al.	GAO	Docket No. SEC.850  177003  OGroup Art Unit 1746		
Serial No.	Filing Date	Examiner	O Group Art Unit		
09/832,330 April 11, 2001		A. Markoff	1746		
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Credit ar Charge a Certificate of	the amount of my overpayment.  In any additional fee required.  Transmission by Facsimile*  Thent and authorization to charge deposite imile transmitted to the United States Office (Factor)	Certificate of Mailing by First Class Mail  I certify that this document and fee is being deposited on with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.  Signature of Person Mailing Correspondence			
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*This certificate m deposit account."  ADAM C. VOLENTINE REG. NO. 33289  VOLENTINE FRANCO: 12200 SUNRISE VALLE RESTON, VA 20191		Dated: July 15, 2003			
TEL. NO. (703)715-0870					
cc:					

## STATEMENT UNDER 37 CFR 1.97(e) ACCOMPANYING Docket No. GROUP 17 2003 1700 Group Art Unit 1746 INFORMATION DISCLOSURE STATEMENT In Re Application Of: Yong-joon CHO et al. Serial No. Filing Date Examiner 09/832,330 April 11, 2001 A. Markoff SEMICONDUCTOR WAFER CLEANING APPARATUS AND METHOD OF USING THE SAME JUL 1 5 2003 TO THE COMMISSIONER FOR PATENTS: This is a statement under the provisions of 37 CFR 1.97(e) in the above-identified application. Check applicable statement herebelow: Statement Under 37 CFR 1.97(e)(1) Each item of information contained in the accompanying Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the Information Disclosure Statement. Statement Under 37 CFR 1.97(e)(2) No item of information contained in the accompanying Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the undersigned person, after making reasonable inquiry, no item of information contained in the accompanying Information Disclosure Statement was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of the Information Disclosure Statement. Dated: JULY 15, 2003 Signature ADAM C. VOLENTINE **REG. NO. 33289** Certificate of Mailing by First Class Mail I certify that this document is being deposited on **VOLENTINE FRANCOS, PLLC** with the U.S. Postal Service as first 12200 SUNRISE VALLEY DRIVE, SUITE 150 class mail under 37 C.F.R. 1.8 and is addressed to the **RESTON VA 20191** Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450. TEL. NO. (703) 715-0870

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